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RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE

IN THE U.S. PATENT AND TRADEMARK OFFICE

February 26, 2003

Applicants: Kazuo NAKAMURA et al

For: BORON-DOPED ISOTOPIC DIAMOND AND  
PROCESS FOR PRODUCING THE SAME

Serial No.: 09/732 799

Group: 1765

Confirmation No.: 2965

Filed: December 8, 2000

Examiner: Kunemund

Atty. Docket No.: OPS Case 421A

Assistant Commissioner for Patents  
Washington, DC 20231

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**AMENDMENT AFTER FINAL REJECTION**

Sir:

In response to the Office Action dated September 23, 2002, Applicants respectfully request entry of the following amendments:

**IN THE CLAIMS**

Please cancel Claim 20.

Please amend Claims 18 and 27 as follows. A marked-up copy is enclosed.

18. (Amended) A method of manufacturing a single crystal diamond p-type semiconductor having a thermal conductivity of from about 26-31 W/cm<sup>2</sup>K and a boron content not exceeding 100 ppm comprising the steps of:

providing a carbonaceous material containing isotopically purified <sup>12</sup>C or <sup>13</sup>C;

providing a flux containing a nitrogen getter;

adding boron into the carbonaceous material or/and the flux, or around the carbonaceous material and the flux; and

diffusing the carbonaceous material into the flux under a high temperature and pressure to form a boron-doped single crystal diamond p-type semiconductor on a seed crystal diamond.